

Notice of References Cited

Application/Control No.

09/661,163

Applicant(s)/Patent Under
Reexamination
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Examiner

Kim Nguyen

Art Unit

3713

Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	C	US-			
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	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

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